BestScope

BMS Series Measuring System



















BEIJING BESTSCOPE TECHNOLOGY CO., LTD.

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Designed for Precision measurement

Reliable quality and technology



BestScope BMS series

Combining high magnification of metallurgical microscope with 3 axises measurement of image measuring instrument, BMS measuring microscope is available for bright&dark field, DIC, polarizing observation, and is widely applied for industrial inspection, such as semiconductor, PCB, LCD, hand phone, optical communication, basic electronics, mold hardware, automobile and so on.

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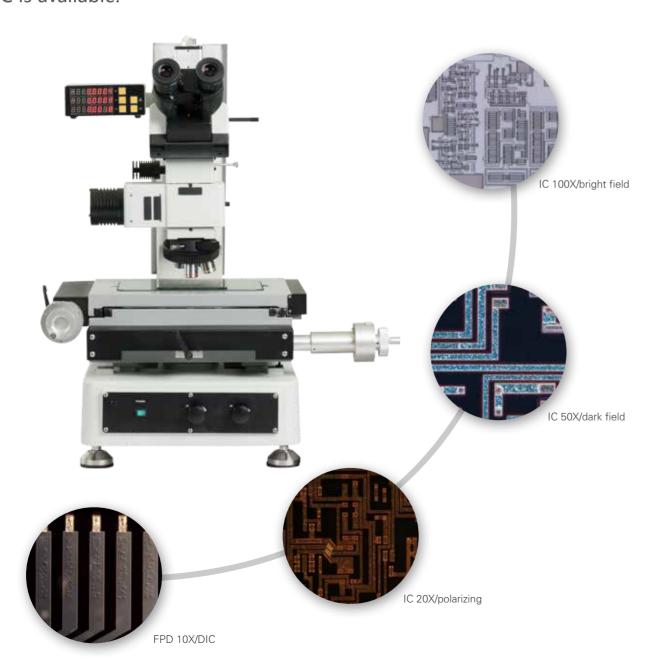
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Outstanding optical technology for excellent imaging

Professional and advanced technology is essential to research and development.

Superior infinity optical system, working with semi apochromatic objectives, presents a sharp image with high contrast and clarity. With simple accessories, different performance such as dark field, polarizing, DIC is available.



5X/10X/20X/50X/100X objectives working with dovetail-type nosepiece, is able for micro-measurement of large parts and small components with wide field, long working distance and high precision.



Long working distance metallurgical objectives

With high transmittance and sharpness lenses, the professional objectives is able to present the real color of samples, support for dark field, polarizing and DIC application.



| Name | Magnification | N.A. | W.D. (mm) | Cover glass (mm) | Parfocal distance (mm) | Conjugate distance |
|---|---------------|------|----------------|--------------------|--------------------------|--------------------|
| Infinity long working distance plan achromatic metallurgical objectives | 5X | 0.15 | 10.8 | | 45 | ∞ |
| | 10X | 0.3 | 12.2 | 0 | | |
| | 50X | 0.55 | 7.9 | | | |
| | 100X | 8.0 | 2.1 | | | |

| Name | Magnification | N.A. | W.D. (mm) | Cover glass (mm) | Parfocal distance (mm) | Conjugate distance (mm) |
|--|---------------|------|----------------|--------------------|--------------------------|---------------------------|
| Infinity long working distance BD plan achromatic metallurgical objectives | 5X | 0.15 | 9.0 | | 45 | ∞ |
| | 10X | 0.3 | 9.0 | 0 | | |
| | 50X | 0.55 | 7.5 | | | |
| | 100X | 8.0 | 2.1 | | | |

| Name | Magnification | N.A. | W.D. (mm) | Cover glass (mm) | Parfocal distance (mm) | Conjugate distance (mm) |
|--|--------------------------|------|----------------|--------------------|--------------------------|---------------------------|
| Infinity super long working distance semi apochromatic | 20X Bright field | 0.4 | 8.8 | 0 | 45 | |
| metallurgical objectives | 20X Bright&dark field | 0.4 | 8.5 | U | 40 | ∞ |

Ergonomics design realizes the comfortable operation

Practice is the basis for research.

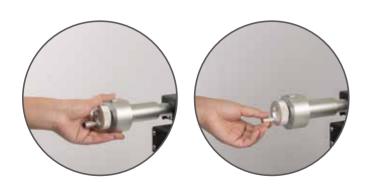
Working efficiency and speed are mainly effected by the tool operability. All design based on ergonomics, reduces the fatigue caused by hard work.

Welcome to experience BMS measuring system.



Tilting viewing head, relieves fatigue from long-time working

With tilting viewing head from 5 to 35 degree, it is available to be comfortably operated by different users with different posture.



Coarse and fine adjustment for X/Y movement, two speed regulation for option

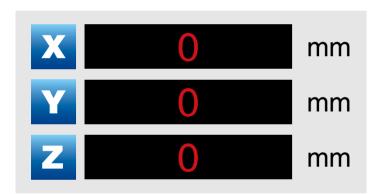
With stage reducer, the stage lead of BMS system can be controlled to 2mm or 4mm, more accurate and easy to operate.



Precision measurement ensures data accuracy

Measurement is aimed at restore the real data of samples.

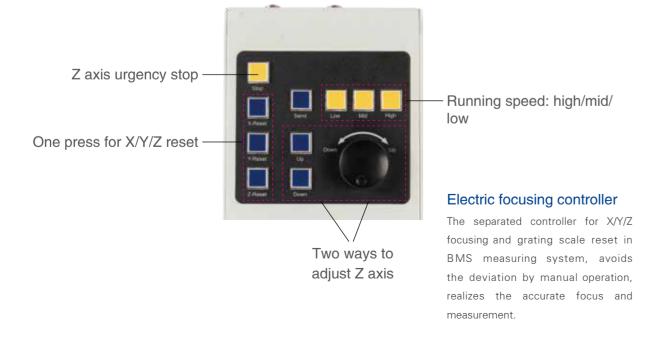
Good measuring tool represents a brand value. With the development of manufacturing technology for miniaturization and precision, high accurate measurement is more and more important. BMS series adopts 3 axises measuring system with 0.1um precision. X/Y axises manual operation and Z axis electric focusing with high accurate grating scales, is easy for operate without fatigue.





High precision grating scale

Z axis electric focusing





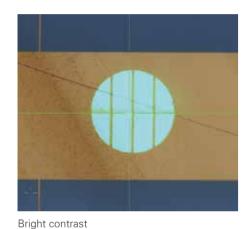


Multi-functional reflected illuminator

With 5W LED, the reflected illuminator is effective and durable. Different color temperature for option, meet all demands. Polarizing kit, filters are attachable.

Independent focus assist of split image

The light controller of split image is independent. Light intensity is able to be adjusted according to different samples. Two patterns of split image for option, support for free switch.









Under focus





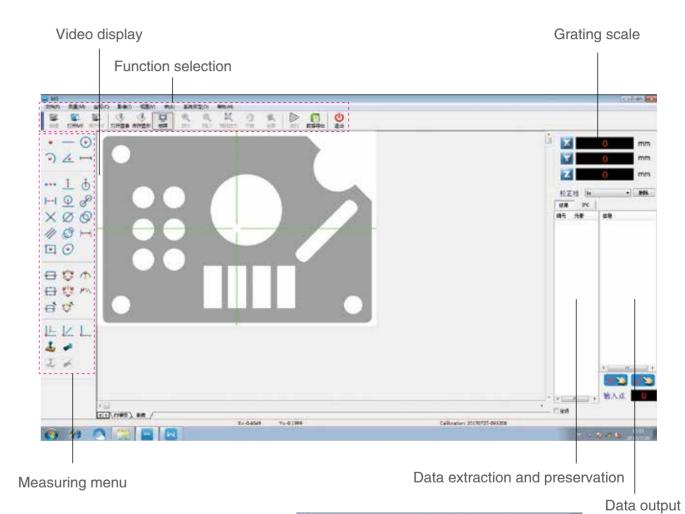




Above focus

Self-designed measuring software, multi-functional and easy to operate

It is available to set up the customer preference by the powerful software. High-precision measurement is achievable for the complicated shapes.



Personalization Freely select the measuring position, delete the output data accordingly.

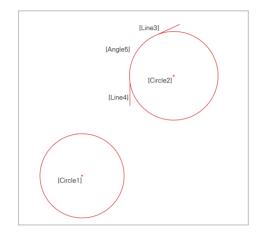
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One button for test report, high efficiency and reliability

Support for report output, to avoid the artificial mistakes during data record.

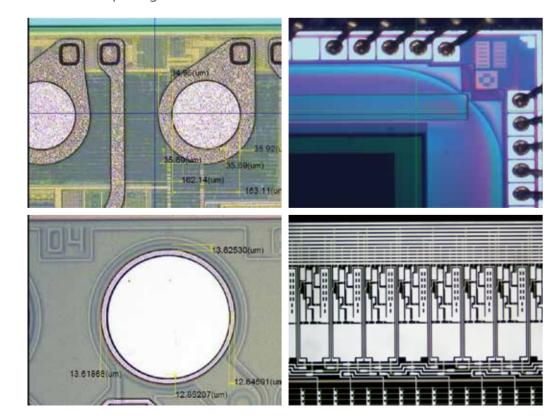
| | Χ | Y | Z | R | А | Angle | Length(2DDistance) | TPlus |
|----------|---------|--------|---|---|---|----------|--------------------|--------|
| Circle 1 | -4.3479 | 9.6989 | 0 | | | | | 1.0751 |
| Circle 2 | -6.6732 | 7.158 | 0 | | | | | 1.1288 |
| Line 3 | 0.3982 | 0.1814 | 0 | | | 24.4916 | 0.4376 | 0 |
| Line 4 | 0.0096 | 0.5355 | 0 | | | -88.973 | 0.5356 | 0 |
| Angle 5 | -5.5487 | 6.4339 | 0 | | | 113.4646 | | |

| TMinus | Straightness | Radius | Diameter | Roundness | Area | Parellel | Perpendicular | 3DDistance |
|--------|--------------|--------|----------|-----------|--------|----------|---------------|------------|
| 1.069 | | 1.0714 | 2.1427 | 0.006 | 3.6061 | | | |
| 1.1228 | | 1.1253 | 2.2507 | 0.006 | 3.9785 | | | |
| 0 | 0 | | | | | | | |
| 0 | 0 | | | | | | | |



Application case

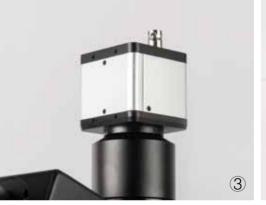
- ★ Bumping size measuring in IC advanced package
- ★ Bumping registration accuracy measuring in IC advanced package
- ★ Welding leg measuring in PCB
- ★ TFT measuring in LCD



Accessory











- ② High eye point wide field plan eyepieces
- ③ 1.3 mega pixels digital camera
- 4 Light controller for split image
- ⑤ Reflected illuminator
- Reflected interference filters





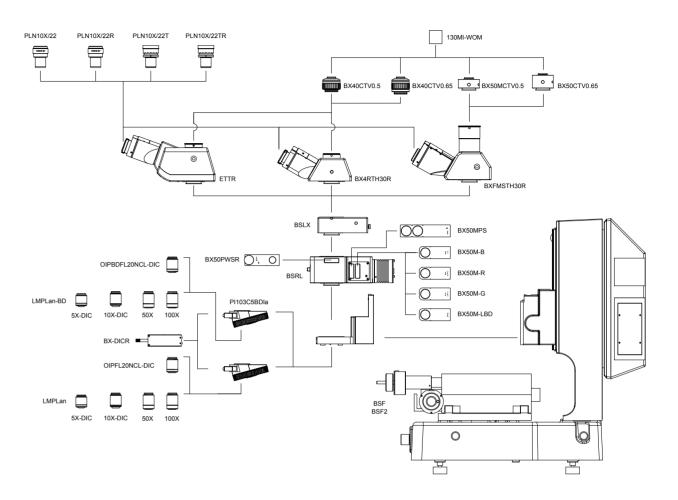
Working stage

Two working stage with different moving range for option, 200mm X 100mm and 300mm X 200mm, to be applied for different samples.

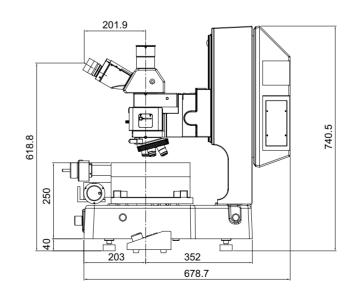
BMS-300 Specification

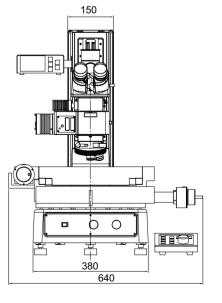
| Optical system | Infinity optical system |
|-------------------|---|
| | 30 degree inclined trinocular head (erect image); interpupillary distance: 50~76mm; splitting ratio: 100:0 or 0:100. |
| Viewing head | 5~35 degree tilting trinocular head (erect image); interpupillary distance: 50–76mm; splitting ratio: 100:0 or 0:100. |
| | 30 degree trinocular head (inverted image); interpupillary distance: 50–76mm; splitting ratio: 100:0 or 50:50. |
| Fuenices | High eye point wide field plan eyepiece PL10X/22mm, reticle attachable. |
| Eyepiece | High eye point wide field plan eyepiece PL10X/22mm, with adjustable diopter, reticle attachable. |
| Naganiaga | Quintuple nosepiece |
| Nosepiece | BD quintuple nosepiece |
| | Long working distance plan achromatic metallurgical DIC objective 5X/10X. |
| | Super long working distance plan semi apochromatic metallurgical DIC objective 20X. |
| Objective | Long working distance plan achromatic metallurgical objective 50X/100X. |
| Objective | Long working distance BD plan achromatic metallurgical DIC objective 5X/10X. |
| | Super long working distance BD plan semi apochromatic metallurgical DIC objective 20X. |
| | Long working distance BD plan achromatic metallurgical objective 50X/100X. |
| Magnification | Optical magnification: 50X~1000X |
| iviagiiiiicatioii | System magnification: 135X~2700X |
| Chara | Manual stage, moving range: 200mm(X) x 100mm(Y), measuring precision: X/Y (2+L/200)um, Z (3+L/200)um; with digital indicator and control box for electric focusing; support for 175mm as the highest. |
| Stage | Manual stage, moving range: 300mm(X) x 200mm(Y), measuring precision: X/Y (2+L/200)um, Z (3+L/200)um; with digital indicator and control box for electric focusing; support for 175mm as the highest. |
| | Reflected illuminator with shifter for bright and dark field; with slots for filters and polarizing kit; 5W LED (green), intensity adjustable. |
| Illumination | Focus assist, with double reticle; 5W LED (green), 100V–240V |
| Focus | Electric hand wheel, focusing distance: 175mm |
| Camera | Color CMOS camera, 1.3 mega pixels, 1280 (H) x 1024 (V); 30fps; USB2.0 |
| Adapter | 0.65X C-mount adapter |
| | 0.5X C-mount adapter |
| PC | LENOVO Think Centre |
| Software | Measuring software |
| Accessory | Polarizer, 360 degree rotatable analyzer, interference filters, high precision micrometer, DIC, calibrater |

BMS-300 System Diagram



BMS-300 Dimension: mm





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